

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

METHOD OF
MANUFACTURING A
SEMICONDUCTOR DEVICE

Attorney Docket Number::

0756-7251

Total Drawing Sheets::

10

Small Entity?::

No

Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Shunpei

Middle Name::

Family Name::

YAMAZAKI

Name Suffix::

City of Residence::

Setagaya

State or Province of Residence::

Tokyo

Country of Residence::

Japan

Street of mailing address::

c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase

City of mailing address::

Atsugi-shi

State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Correspondence Information

Correspondence Customer Number :: 31780
E-Mail address:: erobinson@riplo.com

Representative Information

Representative Customer Number:: 31780

Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	Divisional	10/124,344	04/18/2002
10/124,344	Divisional	09/337,333	06/21/1999

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	10-174482	06/22/1998	Yes

Assignee Information

Assignee name:: Semiconductor Energy
Laboratory Co., Ltd.

Street of mailing address:: 398 Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036